



Docket No. 740107-140

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
Nobuo SHIMAZU et al. ) : Group Art Unit: 2881  
Application No.: 09/765,388 ) : Examiner: Unknown  
Filed: January 22, 2001 )  
For: ELECTRON BEAM PROXIMITY )  
EXPOSURE APPARATUS AND METHOD :

#6  
D-Scott  
2-7-02  
RECEIVED  
SEP 25 2001  
TC 2800 MAIL ROOM

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

The references which are listed on Form PTO-1449 are discussed in the specification.

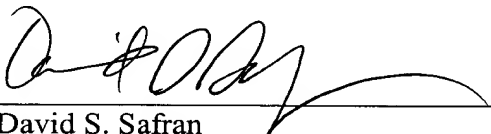
The documents are being submitted within 3 months of the filing, or entry into the national phase, of this application or before the first Office Action on the merits, whichever is later, therefore no fee or certification is required under 37 C.F.R. § 1.97(b).

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialled copy of this form be returned to the undersigned.

Respectfully submitted,

Date: September 24, 2001

NIXON PEABODY LLP  
8180 Greensboro Drive, Suite 800  
McLean, Virginia 22102  
Telephone: (703) 790-9110

By:   
David S. Safran  
Registration No. 27,997